

10/26/01
10/045542
10/26/01
10/045542

H.S.

P

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10045542	10/23/2001	427	317	1762	D. S.

APPLICANTS: Das Mirnai; Lipkin Lori;

**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/294,307 05/20/2001
AND IS A CIP OF 09/834,283 04/12/2001
WHICH CLAIMS BENEFIT OF 60/237,822 10/03/2000
AND CLAIMS BENEFIT OF 60/237,426 10/03/2000

is a CIP of 09/968,391 10/1/2001 which
474 7

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO 5308-157IP2
Title: Method of fabricating an oxide layer on a silicon carbide layer utilizing an anneal in a hydrogen environment		
U.S. DEPT. OF COMM./PAT. & TM-PTO-436 (Rev. 12-94)		

RCE 9/29/03

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
6-27-03		Assistant Examiner	Total Claims 20
ISSUE FEE		MICHAEL BARR PRIMARY EXAMINER	Print Claim for O.G. 1
Amount Due \$1600	Date Paid	<i>Primary Examiner</i>	DRAWING
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Sheets Drwg. 6 Figs. Drwg. 8 Print Fig. 1A
Application Examiner			
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH: DISK (CRF) CD-ROM
(Attached in pocket on right inside flap)